ise No. <u>-00CT17653333</u>

jc997 U.S. PTO 02/20/02

DIRECTOR, U.S. PATENT AND TRADEMARK OFFICE WASHINGTON, DC 20231

Transmitted herewith for filing is the patent application of:

I HEREBY CERTIFY THIS PAPER OR FEE IS BEING DEPOSITED WITH THE U.S. POSTAL SERVICE "EXPRESS MAIL POST OFFICE TO ADDRESSEE" SERVICE UNDER 37 CFR 1.10 ON THE DATE INDICATED BELOW AND IS ADDRESSED TO: BOX PATENT APPLICATIONS, ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

EXPRESS MAIL NO: EL747059970US

2-21-02

DATE OF DEPOSIT: February 20, 2002

NAME: Down Kimler

SIGNATURE:<

inventors:

Vito RAINERI **Mario SAGGIO**

For:

A METHOD FOR MANUFACTURING ISOLTAING STRUCTURES

Enclosed are:

Patent Application: 10 pages, 6 claims
5 sheets of drawings
The suggested drawing figure to be published is FIG. 5.
A Preliminary Amendment
Submission of Proposed Drawing Modification.

Assignee info: Name:

Name: STMicroelectronics S.r.l.
Address: Via C. Olivetti, 2, 20041 Agrate Brianza, Italy
Country of Incorporation: Italy
Applicant claims priority benefit to the following foreign application(s):

Country:

Application No.:

Filing Date:

Italy MI2001A000339 February 20, 2001

The Declaration and Filing Fee are NOT ENCLOSED.

[X]

Name, Address and Citizenship of Inventor(s) is as follows:

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Associate this file with Customer No. 27975.

Date: February 20, 2002

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